

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Applicants :	CHEN ET AL.)	Confirmation No. 8561
)	
Serial No. :	10/733,721)	Examiner: Evan Pert
)	Group Art Unit: 2826
Filed :	11 December 2003.)	
)	TKHR Ref. 250914-1010
For :	Method of Forming Poly-)	Tsai, Lee & Chen Ref. NP-1812-US
	Silicone Thin Film Transistors)	
)	

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Office Action February 10, 2006 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.